

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number	
				50478-2000		<b>10/577979</b> Not yet assigned	
				Applicant(s)		Filing Date	
				Shinichi Yamamoto et al.		10/577979 1 MAY 2006	
				Herewith		Group Art Unit	
						Not yet assigned	

  

U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,34,6775	2.12.2002	Lee, et al.			

  

U.S. PATENT APPLICATION PUBLICATIONS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

  

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2002-117771	4.19.2002	Japan w/English Abstract			X	
		2004-335406	11.25.2004	Japan w/English Abstract			X	
		08-339767	12.24.1996	Japan w/English Abstract			X	
		07-037510	2.7.1995	Japan w/English Abstract			X	
		2000-164141	6.16.2000	Japan w/English Abstract			X	
		2001-222944	8.17.2001	Japan (See USP 6,346,775 Family Patent)			X	
		2001-220674	8.14.2001	Japan w/English Abstract				

  

OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>	
	Whikun Yi et al.; Secondary Electron Emission Yields from MgO deposited on Carbon Nanotubes; Journal of Applied Physics; Vol 89, No. 7; 2001 American Institute of Physics.

  

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	